

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/516,940	FUNAKOSHI ET AL.
	Examiner Jafar Parsa	Art Unit 1621

SEARCHED

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
560	205	1/7/2007	JP
570	139, 172	1/7/2007	JP